

In re the Application of

Toshihiko TSUJI et al.

Application No.: 10/603,807

Filed: June 26, 2003 Docket No.: 116370

For: EXPOSURE METHOD AND EXPOSURE APPARATUS

## **PRELIMINARY AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims;